

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination HA ET AL.	
		Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,005,279	12-1999	Luning, Scott D.	257/510
	B	US-6,294,823	09-2001	Arafa et al.	257/510
	C	US-6,373,119	04-2002	Noda, Kenji	257/510
	D	US-6,022,781	02-2000	Noble et al.	438/296
	E	US-6,303,465	10-2001	Liao, Wei-Wu	438/424
	F	US-6,121,113	09-2000	Takatsuka et al.	438/424
	G	US-6,319,794	11-2001	Akatsu et al.	438/424
	H	US-5,950,090	09-1999	Chen et al.	438/296
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.